FEB 1 6 2006 BY

Att. Docket No. 10191/1690

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. Serial No.

09/762,985

Confirmation No. 2674

Title

DEVICE AND METHOD FOR

ETCHING A SUBSTRATE USING

AN INDUCTIVELY COUPLED PLASMA

Applicant(s)

Volker BECKER et al.

Filed

May 8, 2001

TC/A.U.

1763

Examiner

T T

Docket No.

Luz L. Alejandro, Muler that this correspondence is being deposited with the 10191/169 United States Postal Service with sufficient postage as first class mail

in an envelope addressed to:

Customer No. :

26646

Mail Stop_____

Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

Mail Stop AF

Man Stop At

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Date.__

Signature:

AARON C DEDITO

(33,865)

AMENDMENT AFTER A FINAL OFFICE ACTION

SIR:

In response to the Final Office Action mailed on September 19, 2005 (the three-month response date for which is December 19, 2005 which has been extended by one month to January 19, 2006 by the accompanying petition), please reconsider the above-identified application based on the following:

Amendments to the Claims are reflected in the listing of the claims which begins on page 2 of this paper.

Remarks begin on page 8 of this paper.